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CONFIRMATION NO. 1091

<b>SERIAL NUMBER</b> 09/830,092	<b>FILING OR 371(c) DATE</b> 06/27/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 1722	<b>ATTORNEY DOCKET NO.</b> ROH-037	
<b>APPLICANTS</b> Kazutaka Shibata, Kyoto, JAPAN;					
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP00/05596 08/22/2000 <i>ms</i>					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 11/235619 08/23/1999 <i>ms</i> JAPAN 11/235620 08/23/1999 <i>ms</i> JAPAN 11/257589 09/10/1999 <i>ms</i> JAPAN 11/292703 10/14/1999 <i>ms</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE</b> <b>GRANTED ** 01/02/2002</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Verified and Acknowledged <i>ms</i> Allowance Examiner's Signature Initials <i>ms</i>		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 14	<b>TOTAL CLAIMS</b> 25	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> Mr. Steven M. Rabin c/o RABIN & BERDO, P.C. 1101 14th Street, NW Suite 500 Washington, DC20005					
<b>TITLE</b> Semiconductor device and method for manufacturing the same					
<b>FILING FEE RECEIVED</b> 1240	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		